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To Commissioner For Patents

Enclosed herewith is a Form PTO-1449, required copies of documents listed thereon, and a concise explanation of their relevance is described below or enclosed herewith per 37 CFR 1.97.

Application Number	09/614,156
Filing Date	JULY 11, 2000
First Named Inventor	HANS W. VAN KESTEREN
Group Art Unit	2754
Examiner Name	
Attorney Docket Number	NL000305

These documents may be relevant in that they have been:

- considered in drafting the specification of the above-referenced application;
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SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT REQUIRED

Name (Print Type)	MICHAEL E. BELK	Registration No. (Attorney/Agent)	33,357
Signature	<i>Michael E. Belk</i>	Date	5/24/01

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